Application No. 10/569,167 Preliminary Amendment

Attorney Docket No. <u>06089/LH</u>

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant(s): Keiichi TANAKA

Serial No. 10/569,167

Deposited February 22, 2006

For VACUUM DEVICE, OPERATION

METHOD FOR VACUUM DEVICE.

EXPOSURE SYSTEM, AND OPERATION METHOD FOR

EXPOSURE SYSTEM

Art Unit

Examiner

PRELIMINARY AMENDMENT

Commissioner for Patents P.O. Box 1450 Alexandria, VA 22313-1450

SIR:

Please amend the above-identified application as follows:

Amendments to the Specification begin on page 2 of this paper.

Amendments to the Drawings begin on page 3 of the paper

Remarks begin on page 4 of this paper.

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Date of Deposit: October 24, 2006

I hereby certify that this paper is being deposited with the United States Postal Service with sufficient postage "Express Mail Post Office to Addressee" service under 37 CFR 1.10 on the date indicated above and is addressed to Mail Stop PCT, Commissioner for Patents,

P.O. Box 1450, Alexandria VA 22313-1450

In the event that this Paper is late filed, and the necessary petition for extension of time is not filed

concurrently herewith, please consider

this as a Petition for the requisite extension of time, and to the extent

not tendered by credit card (Form PTO-2038 attached hereto), authorization to charge the extension fee, or any other fee required in connection with this Paper to Account

No. 06-1378.